

EV 335728716 US INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) MTU-01		Application Number PCT/EP2004/003620	
				Applicant(s) Armin Dolker		10/552928	
				Filing Date 11 OCT 2005		Group Art Unit	

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AC		US 6,366,049 B1	04/02/02	Chen, et al	318	799	05/10/00
AC		US 5,613,474 A	3/25/97	Nakamura, et al	123	496	08/10/94

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
AC		WO 03/098793 A	11/27/03	PCT	—	—		
AC		DE 102 21 681	11/27/03	Germany	—	—		✓
AC		DE 102 52 399	6/3/04	Germany	—	—		✓

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER 	DATE CONSIDERED 12-21-2006
--------------	--------------------------------------

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.